



12500 TI Boulevard, MS 8640, Dallas, Texas 75243

PCN# 20120914002

**Qualification of RFAB as an additional FAB Site Option for Select TPA2015D1YZH
Devices in the LBC7 Process
Change Notification / Sample Request**

Date: 9/19/2012
To: MOUSER PCN

Dear Customer:

This is an announcement of a change to a device that is currently offered by Texas Instruments. The details of this change are on the following pages.

We request you acknowledge receipt of this notification within **30** days of the date of this notice. Lack of acknowledgement of this notice within 30 days constitutes acceptance of the change. If you require samples or additional data to support your evaluation, please request within 30 days.

The changes discussed within this PCN will not take effect any earlier than **90** days from the date of this notification, unless customer agreement has been reached on an earlier implementation of the change. This notification period is per TI's standard process.

This notice does not change the end-of-life status of any product. Should product affected be on a previously issued product withdrawal/discontinuance notice, this notification does not extend the life of that product or change the life time buy offering/discontinuance plan.

For questions regarding this notice, contact your local Field Sales Representative or the PCN Manager (PCN_ww_admin_team@list.ti.com).

PCN Team
SC Business Services
Phone: +1(214) 480-6037
Fax: +1(214) 480-6659

20120914002
Attachment: 1

Products Affected:

The devices listed on this page are a subset of the complete list of affected devices. According to our records, these are the devices that you have purchased within the past twenty-four (24) months. The corresponding customer part number is also listed, if available.

DEVICE	CUSTOMER PART NUMBER
TPA2015D1YZHT	null

Technical details of this Product Change follow on the next page(s).

PCN Number:	PCN20120914002			PCN Date:	09/19/2012
Title:	Qualification of RFAB as an Additional FAB Site Option for Select TPA2015D1YZH Devices in the LBC7 Process				
Customer Contact:	PCN Manager	Phone:	+1(214)480-6037	Dept:	Quality Services
*Proposed 1st Ship Date:	12/19/2012	Estimated Sample Availability:			Date provided at sample request.
Change Type:					
<input type="checkbox"/>	Assembly Site	<input type="checkbox"/>	Assembly Process	<input type="checkbox"/>	Assembly Materials
<input type="checkbox"/>	Design	<input type="checkbox"/>	Electrical Specification	<input type="checkbox"/>	Mechanical Specification
<input type="checkbox"/>	Test Site	<input type="checkbox"/>	Packing/Shipping/Labeling	<input type="checkbox"/>	Test Process
<input type="checkbox"/>	Wafer Bump Site	<input type="checkbox"/>	Wafer Bump Material	<input type="checkbox"/>	Wafer Bump Process
<input checked="" type="checkbox"/>	Wafer Fab Site	<input type="checkbox"/>	Wafer Fab Materials	<input type="checkbox"/>	Wafer Fab Process

PCN Details

Description of Change:

This notification is to announce the qualification of RFAB as an additional FAB site option for select TPA2015D1YZH devices in the LBC7 Process.

Currently Qualified Site, process	Additional Site, Process
MIHO8, LBC7 Process	RFAB, LBC7 Process

The LBC7 process was previously qualified at RFAB on 3/3/2011. Qualification details are shown in the Qualification Data Section of this document.

Reason for Change:

Continuity of Supply

Anticipated impact on Form, Fit, Function, Quality or Reliability (positive / negative):

None

Changes to product identification resulting from this PCN:

Chip Site:

Current

Chip Site	Chip site code (20L)	Chip country code (21L)
MIHO8	MH8	JPN

New

Chip Site	Chip site code (20L)	Chip country code (21L)
RFAB	RFB	USA

Sample product shipping label (not actual product label)



Product Affected:									
HPA01080YZHR		TPA2015D1YZHR		TPA2015D1YZHT					
Qualification Data: Approval Date 3/3/2011									
This qualification has been developed for the validation of this change. The qualification data will validate that the proposed change meets the applicable released technical specifications.									
Qual Vehicle 1: TPIC2020RTQRG4									
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN						
Wafer Fab Process:	LBC7	Wafer diameter:	300mm						
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results									
Reliability Test		Conditions		Sample Size					
				Lot#1	Lot#2				
Life Test		1000/125C/Vmax		80/0	80/0				
**Biased HAST		96/130C/85%/Vmax		80/0	-				
**Autoclave 121C		96/121C/2 atm		80/0	-				
**Temperature Cycle		1000/-65/150C		80/0	80/0				
**High Temp. Storage Bake		150C (1000 Hrs)		80/0	-				
ESD HBM		2000V		27/0	27/0				
ESD CDM		750V		3/0	3/0				
**Thermal Path Integrity		Per appropriate package level		12/0	12/0				
Latch-up		(per JESD78)		6/0	6/0				
** Preconditioning sequence: level 3 @ 260C peak +5/-0C									
Qual Vehicle 2: TPS65830YFFR									
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN						
Wafer Fab Process:	LBC7	Wafer diameter:	300mm						
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results									
Reliability Test		Conditions		Sample Size					
				Lot#1	Lot#2				
**Unbiased HAST 130C/85%RH		96/-		38/0	38/0				
**Temperature Cycle		-55/125C 1000 Cycles		39/0	38/0				
ESD HBM		2000V		1/0	1/0				
ESD CDM		500V		1/0	1/0				
Latch-up		(per JESD78)		3/0	3/0				
** Preconditioning sequence: level 1 @ 260C peak +5/-0C									
Qual Vehicle 3: TPS65170RHDR									
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN						
Wafer Fab Process:	LBC7	Wafer diameter:	300mm						

Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results						
Reliability Test		Conditions		Sample Size		
				Lot#1	Lot#2	Lot#3
**Autoclave 121C		96/121C		38/0	38/0	38/0
**Temperature Cycle		-65/150C 1000 Cycles		39/0	39/0	39/0
**Thermal Shock		-65/150C 1000 Cycles		38/0	38/0	38/0
ESD HBM		2000V		3/0	3/0	3/0
ESD CDM		750V		3/0	3/0	3/0
Moisture Sensitivity, L2		Visual-1/40X		12/0	-	-
Moisture Sensitivity, L2		CSAM-1/100%		12/0	-	-
Moisture Sensitivity, L2		ThruSAM-1/100%		12/0	-	-
Moisture Sensitivity, L2		24/125C		12/0	-	-
Moisture Sensitivity, L2		168/85C / 60%		12/0	-	-
Moisture Sensitivity, L2		3/260C +5 / -0C		12/0	-	-
Moisture Sensitivity, L2		Visual-2/40X		12/0	-	-
Moisture Sensitivity, L2		Elec/25C		12/0	-	-
Moisture Sensitivity, L2		CSAM-2/100%		12/0	-	-
Moisture Sensitivity, L2		ThruSAM-2/100%		12/0	-	-
** Preconditioning sequence: level 3 @ 260C peak +5/-0C						
Qual Vehicle 4: TLS2602DCARG4						
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN			
Wafer Fab Process:	LBC7	Wafer diameter:	300mm			
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results						
Reliability Test		Conditions		Sample Size		
				Lot#1	Lot#2	Lot#3
Life Test, 125C		1000/125C Vmax		80/0	80/0	80/0
**Autoclave 121C		96/121C/2atm		80/0	-	-
**Temperature Cycle		-65/150C 1000 Cycles		39/0	39/0	39/0
ESD HBM		2000V		3/0	3/0	3/0
ESD CDM		750V		3/0	3/0	3/0
**Thermal Path Integrity, L3-260C		PRE VM		12/0	-	-
**Thermal Path Integrity, L3-260C		PRE SAM/CSAM/TSAM		12/0	-	-
**Thermal Path Integrity, L3-260C		Bake 24hr/125C		12/0	-	-
**Thermal Path Integrity, L3-260C		Soak 192hr/30C/60%		12/0	-	-
**Thermal Path Integrity, L3-260C		Reflow x3/260C +5/-0		12/0	-	-
**Thermal Path Integrity, L3-260C		POST VM		12/0	-	-
**Thermal Path Integrity, L3-260C		DC TEST		12/0	-	-
**Thermal Path Integrity, L3-260C		POST SAM/CSAM/TSAM		12/0	-	-
**Thermal Path Integrity, L3-260C		T/C 500cy/-65C/150C		12/0	-	-
**Thermal Path Integrity, L3-260C		POST TC SAM/CSAM/TSAM		12/0	-	-
Latch-up		CI/100mA		6/0	6/0	6/0
Latch-up		OV/1.5Vmax		6/0	6/0	6/0
** Preconditioning sequence: level 3 @ 260C peak +5/-0C						

Qual Vehicle 5: TPS62620YFFR						
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN			
Wafer Fab Process:	LBC7	Wafer diameter:	300mm			
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results						
Reliability Test	Conditions			Sample Size		
				Lot#1	Lot#2	Lot#3
Temperature Cycle	-55/125C 1000 Cycles			80/0	80/0	80/0
ESD HBM	2000V			3/0	3/0	3/0
ESD CDM	750V			3/0	3/0	3/0
Signal Latch-up	before/85C			6/0	6/0	6/0
Signal Latch-up	after/85C			6/0	6/0	6/0
Qual Vehicle 6: TPA6140A2YFFR						
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN			
Wafer Fab Process:	LBC7	Wafer diameter:	300mm			
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results						
Reliability Test	Conditions			Sample Size		
				Lot#1	Lot#2	Lot#3
L/T 140C	480/-			38/0	39/0	40/0
**Unbiased HAST 130C/85%RH	96/-			39/0	39/0	39/0
**Temperature Cycle	-55/125C, 1000V			3/0	3/0	3/0
ESD HBM	2000V			3/0	3/0	3/0
ESD CDM	750V			3/0	3/0	3/0
Latch-up	Latchup			6/0	6/0	6/0
Latch-up	Elec Test			6/0	6/0	6/0
** Preconditioning sequence: level 3 @ 260C peak +5/-0C						

For questions regarding this notice, e-mails can be sent to the regional contacts shown below, or you can contact your local Field Sales Representative.

Location	E-Mail
USA	PCNAmericasContact@list.ti.com
Europe	PCNEuropeContact@list.ti.com
Asia Pacific	PCNAsiaContact@list.ti.com
Japan	PCNJapanContact@list.ti.com